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APPLICANTS

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** CONTINUING DATA *****
 NONE *DL*

** FOREIGN APPLICATIONS *****
 REPUBLIC OF KOREA 2003-713 01/07/2003 *DL*

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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged	Examiner's Signature <i>[Signature]</i>	Initials		

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TITLE
 Method for forming gate oxide in semiconductor device

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